

GUJARAT TECHNOLOGICAL UNIVERSITY
ME - SEMESTER-1 (NEW) EXAMINATION – WINTER 2018

Subject Code: 3710808**Date: 04/01/2019****Subject Name: Advanced Metrology and Experimental Techniques****Time: 02:30 PM To 05:00 PM****Total Marks: 70****Instructions:**

1. Attempt all questions.
2. Make suitable assumptions wherever necessary.
3. Figures to the right indicate full mark.

- Q.1** (a) What is the difference between Accuracy and Precision ? State necessity of high precision measurement. **07**
- (b) Write note on “Inaccuracy due to thermal aspects.” **07**
- Q.2** (a) (i) Why Surface finish is important in engineering applications? **03**
(ii) Explain the following terms : Roughness, Waviness and Form **04**
- (b) With suitable example, discuss Experimental Design Protocol. **07**
- OR**
- (b) Which methods are used for improving accuracy? Discuss them briefly. **07**
- Q.3** (a) Explain advanced techniques used in Metrology briefly. **07**
- (b) Explain Types of Experimental errors and their causes. **07**
- OR**
- Q.3** (a) What do you mean by Co-ordinate Metrology? Explain CMM configurations briefly. **07**
- (b) What do you understand by Image enhancement? Explain gray scale models used for machine vision system. **07**
- Q.4** (a) Explain overview of Image processing briefly. **07**
- (b) The following results are observed using pressure gauge : **07**
2.96, 2.97, 2.98, 3.00, 3.01, 3.02, 3.03, 3.04, 3.05, 3.06 Pascal
Calculate Arithmetic mean, Average deviation, Standard deviation and Variance.
- OR**
- Q.4** (a) Discuss how LASER interferometer can be used for distance measurement. **07**
- Q.4** (b) Describe Chi-Square Test of Goodness of fit. **07**
- Q.5** (a) State basic principle of Holography. Explain double exposure holographic interferometry. **07**
- (b) Discuss significant aspects of LASER Metrology. **07**
- OR**
- Q.5** (a) Discuss different types of experiments. **07**
- (b) Explain in brief Probe sensor and Displacement device used in CMM. **07**
